

ITW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **ROBIN LYNN
ALMES ET AL.**

Serial No.: 10/823,981

Filed: 14 APRIL 2004

For: **SYSTEM AND METHOD FOR
CHARGE-BALANCED,
CONTINUOUS-WRITE MASK AND
WAFER PROCESS FOR IMPROVED
COLINEARITY**

§ Attorney Docket No. **HSJ920040029US1**

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Examiner: **UNKNOWN**

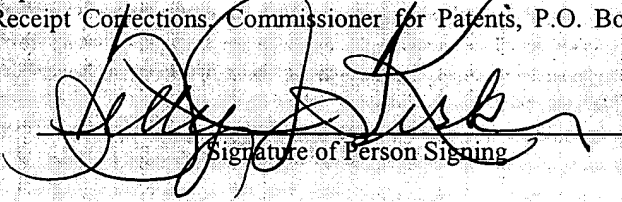
Art Unit: **2812**

REQUEST FOR CORRECTED FILING RECEIPT

O.I.P.E. – Filing Receipt Corrections
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants hereby request that a Corrected Filing Receipt be issued for the above-identified patent application. Please amend the Filing Receipt as follows:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to O.I.P.E. – Filing Receipt Corrections, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 10, 2004.	
Betty J. Kirk _____ Type Name of Person Signing	 _____ Signature of Person Signing

It is hereby requested that a correction be made under the caption "**Attorney Docket No.**" on the face of the Filing Receipt. The Attorney Docket No. is incorrectly cited as "HSJP920030029US1" when in fact, the Attorney Docket No. is:-- **HSJ920040029US1**-- . Please correct the Filing Receipt to reflect the correct Attorney Docket No., which is:

--HSJ920040029US1--.

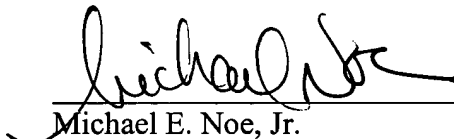
Further, it is hereby requested that a correction be made under the caption "Applicant(s)" on the face of the Filing Receipt. The third Applicant is incorrectly listed as: "Mary Kathryn Gutberlet" when in fact, her name is -- **Mary Kathryn Gutberlet** --. Please correct the Filing Receipt to reflect the third Applicant's correct name, which is:

-- Mary Kathryn Gutberlet --.

A photocopy of the Filing Receipt with the requested changes noted thereon is enclosed for reference.

No fee is believed to be required at this time; however, in the event any fees are required, please charge **Hitachi Global Storage Technologies' Deposit Account No. 50-2587**.

Respectfully submitted,



Michael E. Noe, Jr.
Registration No.: 44,975
BRACEWELL & PATTERSON, L.L.P.
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ATTORNEY FOR APPLICANT(S)



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/823,981	04/14/2004	2812	990	HSJ920030029US1	4	25	2

BRACEWELL & PATTERSON, L.L.P.
P.O. BOX 61389
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HSJ920030029US1
HSTJ920040029US1

CONFIRMATION NO. 5316

UPDATED FILING RECEIPT



OC000000013355311

Date Mailed: 07/27/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Robin Lynn Almes, Sunnyvale, CA; ✓
Mark Anthony Church, Los Gatos, CA; ✓
Mary Kathryn Gutberlet, Prunedale, CA; ✓
Jiunn Tsay, San Jose, CA; ✓
Benjamin Lu Chen Wang, San Jose, CA; ✓

Kathryn

Received	
Bracewell & Patterson, L.L.P.	
JUL 30 2004	
Docket By	<u>Pz</u>
Action	_____
Due Date	_____

Assignment For Published Patent Application

Hitachi Global Storage Technologies Netherlands B.V.;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted: 06/23/2004

Projected Publication Date: 10/20/2005

Non-Publication Request: No

Early Publication Request: No

Title

System and method for charge-balanced, continuous-write mask and wafer process for improved

**LICENSE FOR FOREIGN FILING UNDER
Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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NOT GRANTED

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